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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)										
A.M	AW	L. D. Zhang, et al., "Dielectric Behaviour of Nano-TiO <sub>2</sub> Bulks", phys. stat. sol. (a) 157, 483, 1996, pgs. 483-491								
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Examiner ANH D. MAI							Date Considered 7/12/02			
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